



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

HONG et al.

Atty. Ref.: 2826-9

Serial No. 10/047,119

Group: 2878

Filed: January 17, 2002

Examiner:

For: METHOD AND APPARATUS FOR CUTTING A MULTI-LAYER
SUBSTRATE BY DUAL LASER IRRADIATION

* * * * *

October 30, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

Attention is invited to the attached copy of a Notice of Refusal (with English language translation) issued by the Japan Patent Office on September 2, 2003 with respect to this disclosure and a copy of each document cited in it. A completed Form PTO-1449 is also attached.

Official citation and consideration of all the attached documents is requested. Please return to the undersigned a copy of the attached PTO-1449 with the examiner's initials in the left column [MPEP §609] with the next communication.

I hereby certify that each item of information contained herein was first cited in any communication from a foreign patent office in a counterpart foreign application not more than 3 months from the filing date of this statement [see 37 C.F.R. § 1.97(e) (1)].

The filing of an Information Disclosure Statement shall not be construed as a representation that a search has been made, an admission that the information cited is, or is considered to be, material to patentability [37 C.F.R. § 1.97(g) & (h)] or that no other material information exists.

RECEIVED
NOV 03 2003
GROUP 1700

Respectfully submitted,

NIXON & VANDERHYE P.C.

By:



John R. Lastova
Reg. No. 33,149

JRL:at

1100 North Glebe Road, 8th Floor
Arlington, VA 22201-4714
Telephone: (703) 816-4000
Facsimile: (703) 816-4100

INFORMATION DISCLOSURE CITATION

ATTY. DOCKET NO.

SERIAL NO.

2826-9

10/047,119

HONG et al.

FILING DATE

GROUP

January 17, 2002

2878

Use several sheets if necessary)

OCT 30 2003

CAMINOS DE

U.S. PATENT DOCUMENTS

FILING DATE

FOREIGN PATENT DOCUMENTS

TRANSLATION

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

Japan Notice of Refusal and English translation

*E

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.